

Title. X-RAY EXPOSURE METHOD
Inventors: KISE et al.
Atty Docket No.: 402786
Leydig, Voit & Mayer
202-737-6770

FIG.1

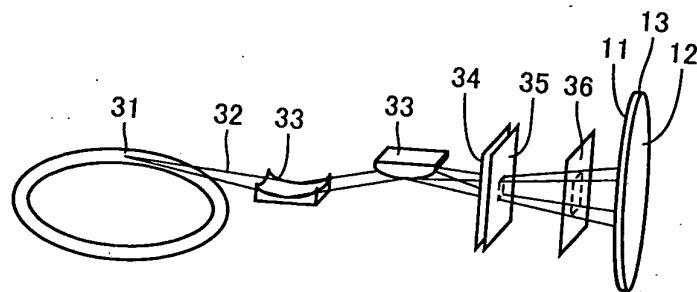


FIG.2

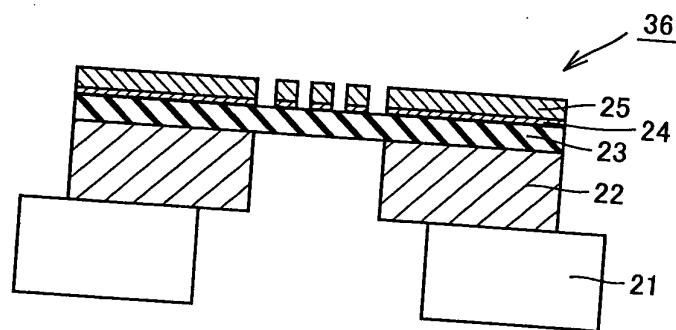
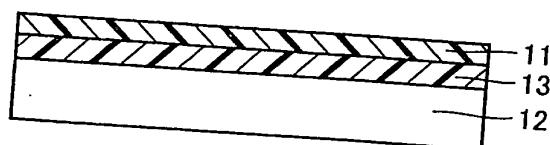


FIG.3



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FIG.4

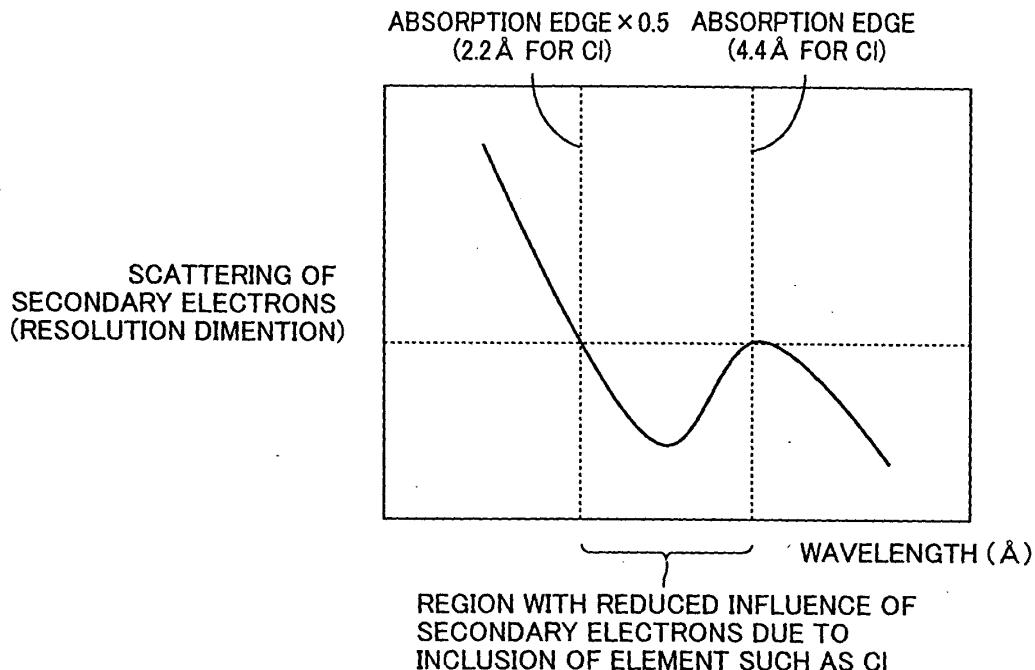
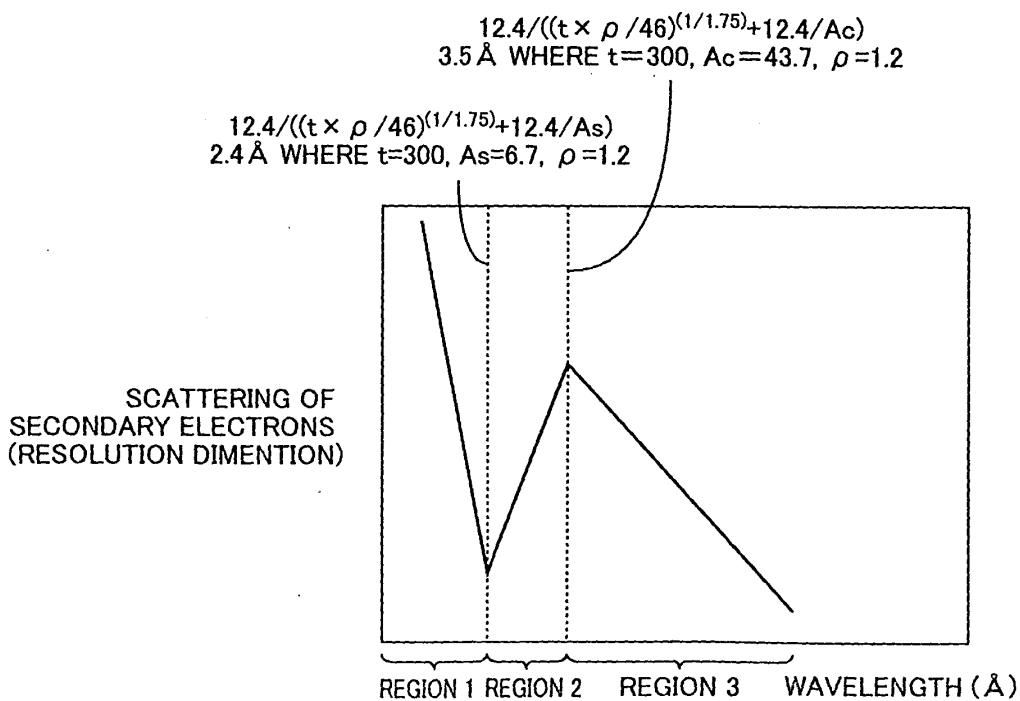


FIG.5



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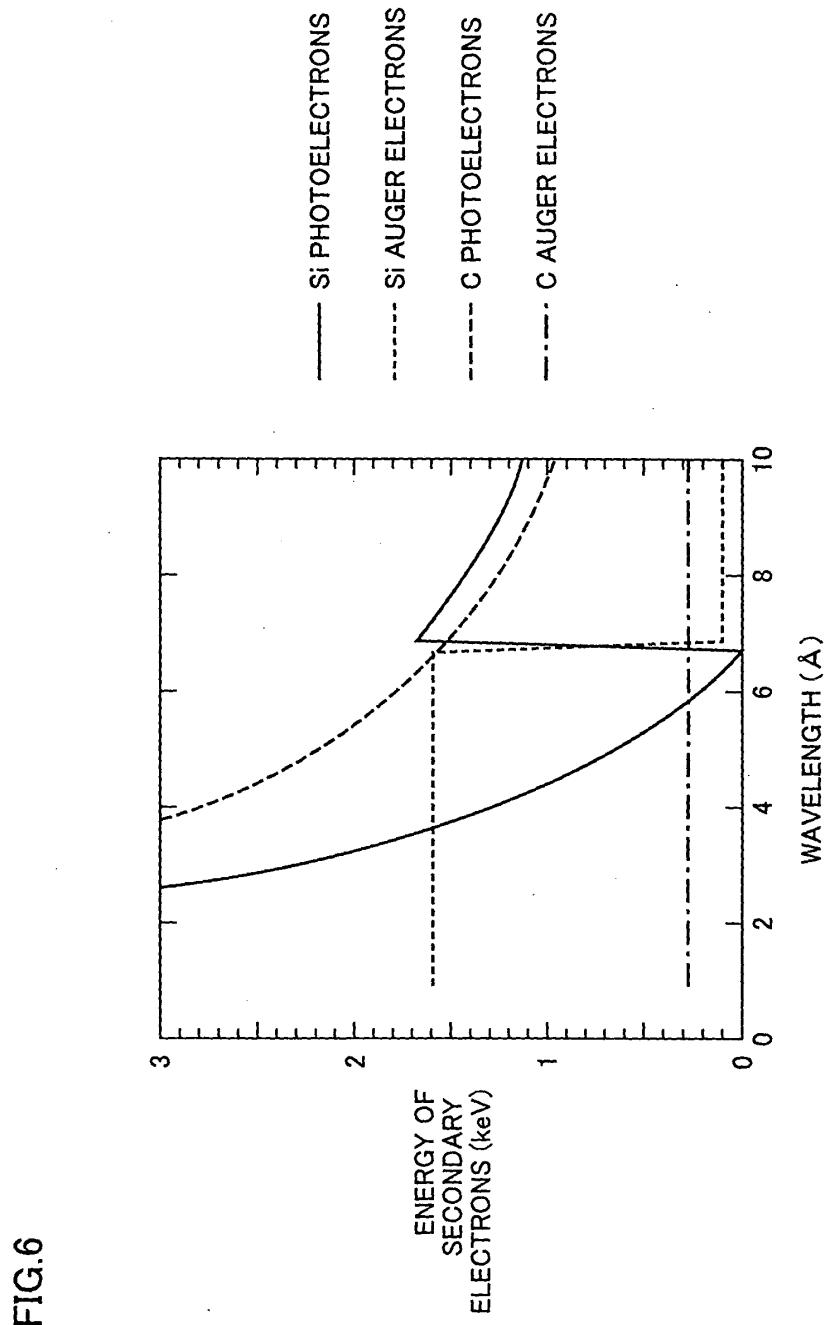
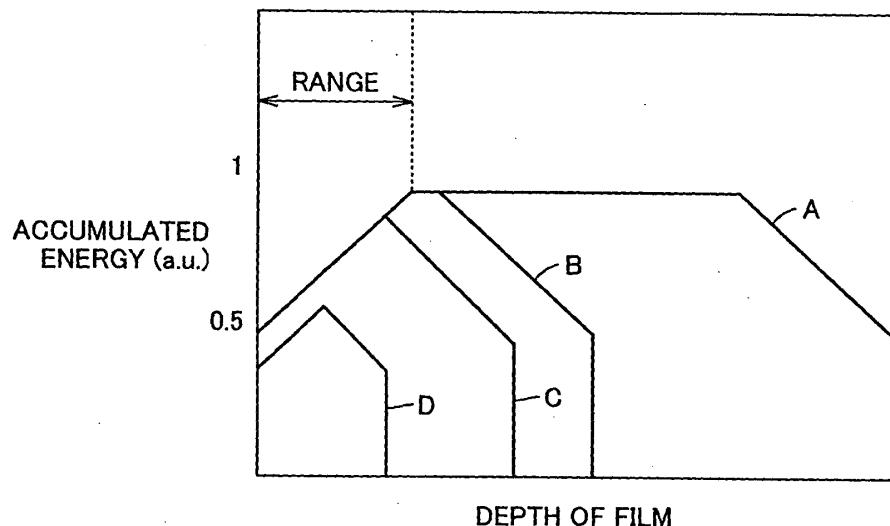


FIG.6

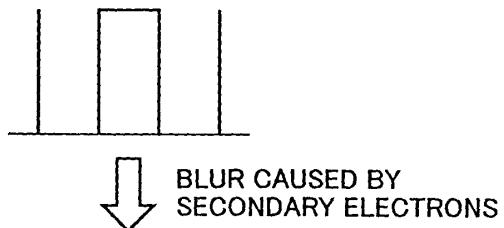
FIG.7



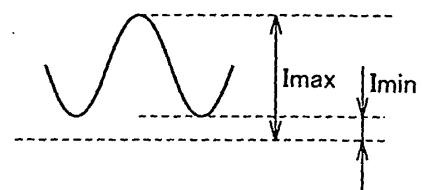
A: FILM THICKNESS>RANGE
B: FILM THICKNESS>RANGE (THINNER THAN A)
C: FILM THICKNESS>RANGE (THINNER THAN A, B)
D: FILM THICKNESS<RANGE

FIG.8

RECTANGULAR OPTICAL IMAGE



DISTRIBUTION OF ENERGY ACCUMULATED IN RESIST



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FIG.9

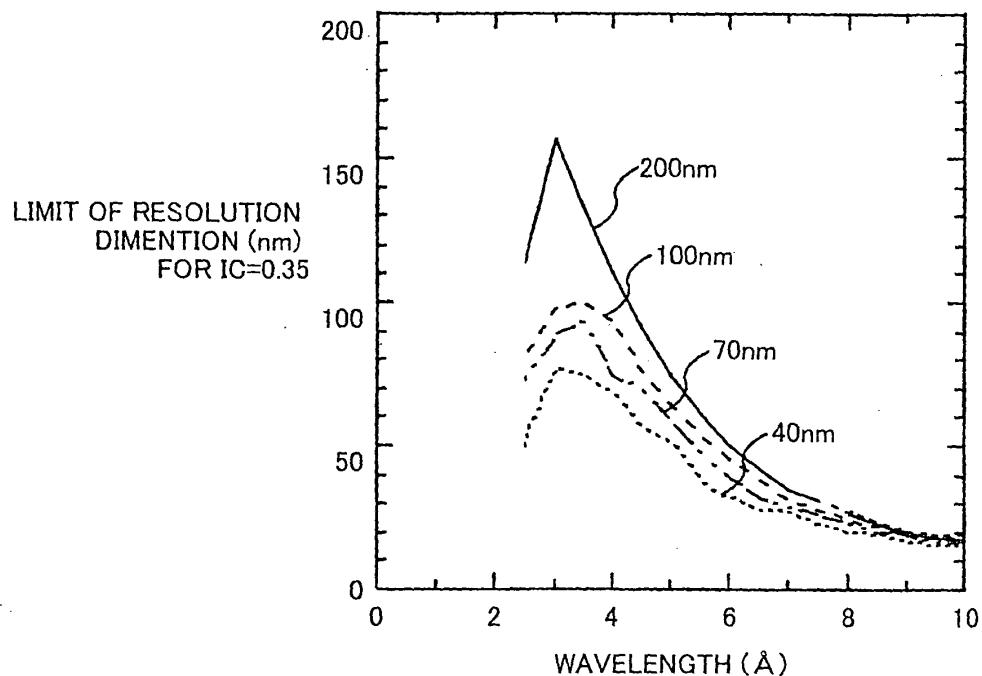
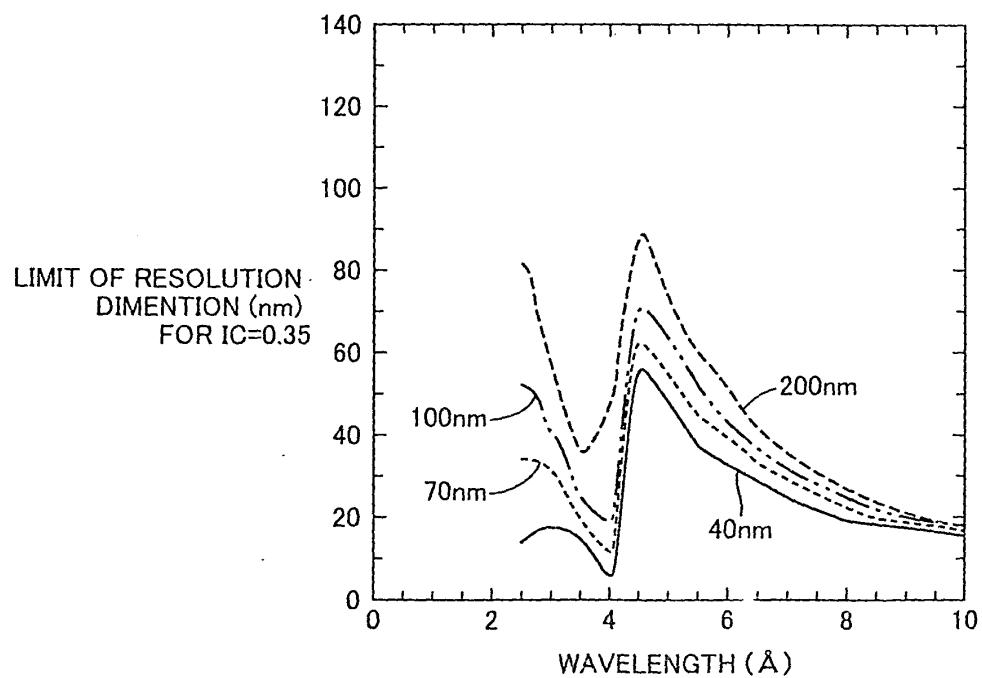


FIG.10



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FIG.11

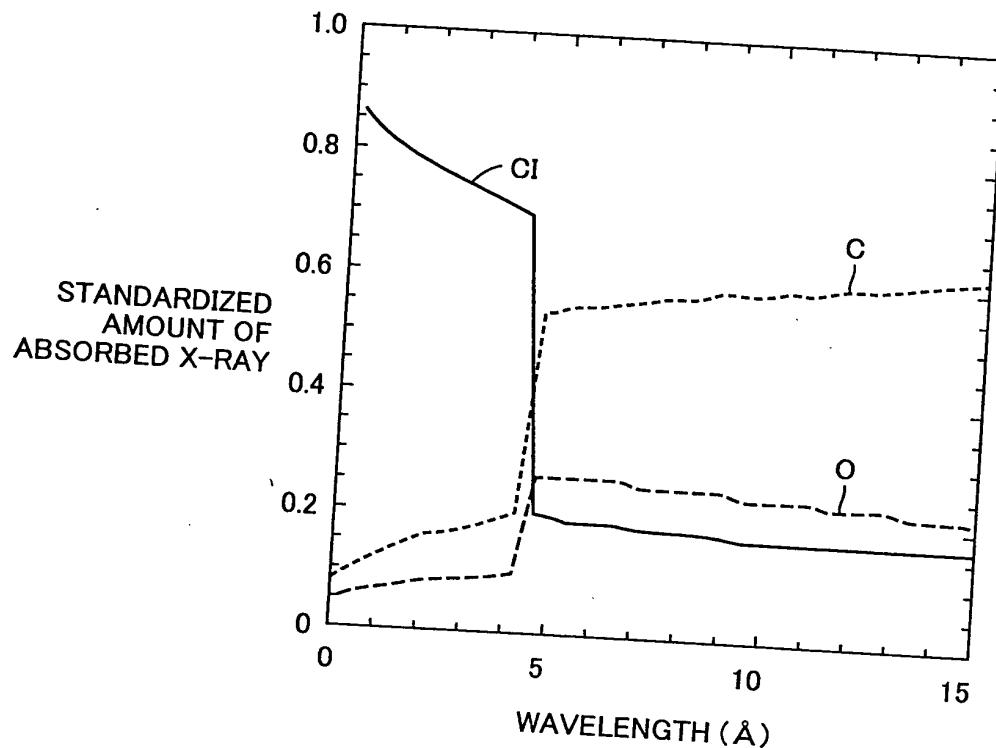


FIG.12

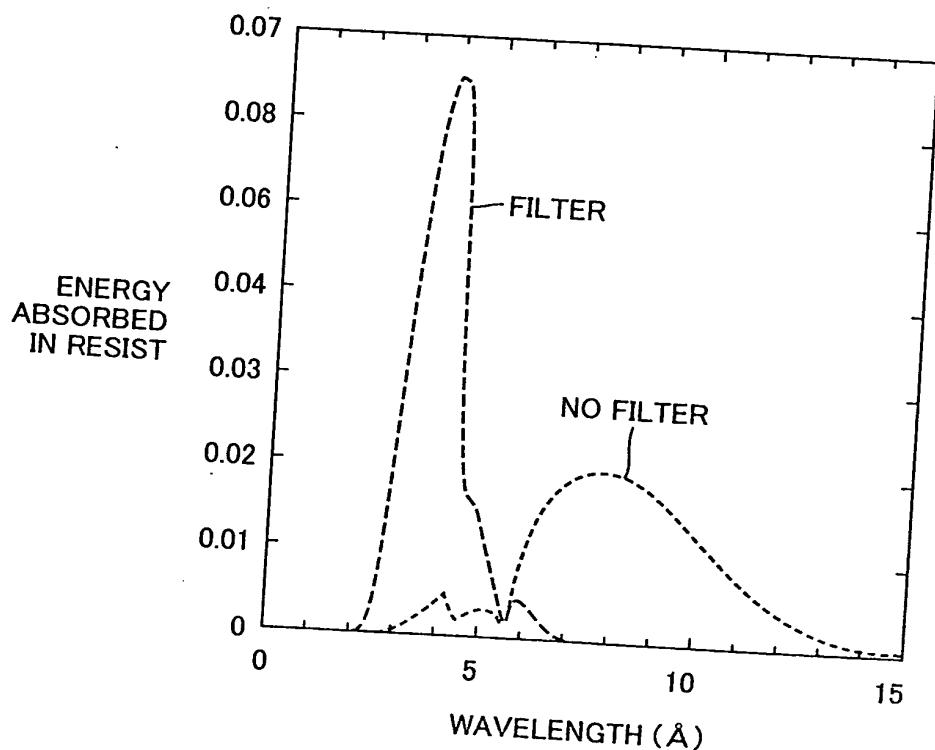


FIG.13A

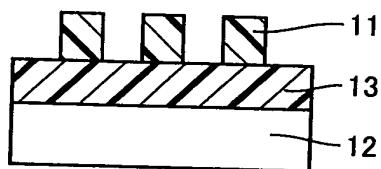


FIG.13B

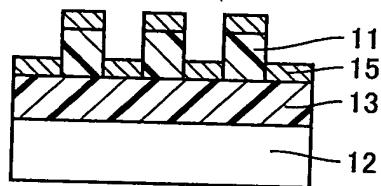


FIG.13C

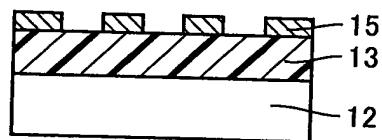


FIG.13D

